

DOCKET NO: 264741US-2 PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
AKIRA AKASAKA, ET AL. : EXAMINER: ELVE, MARIA A.
SERIAL NO: 10/523,392 :
FILED: FEBRUARY 3, 2005 : GROUP ART UNIT: 3742
FOR: LASER PROCESSING DEVICE, :
PROCESSING METHOD, AND METHOD
OF PRODUCING CIRCUIT SUBSTRATE
USING THE METHOD

AMENDMENT UNDER 37 C.F.R. § 1.111

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action of February 3, 2010, please amend this application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.